

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 1773

Application No.: 10/724,635

Examiner:

Filed: December 2, 2003

Docket No.: 117926

For:

METHOD OF MANUFACTURING OXIDE THIN FILM, METHOD OF

MANUFACTURING FERROELECTRIC THIN FILM, FERROELECTRIC THIN FILM. FERROELECTRIC MEMORY DEVICE, AND FERROELECTRIC PIEZOELECTRIC

DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- \bowtie This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- \bowtie 2. The references were cited in a counterpart foreign application. An English language version of the Chinese search report is attached for the Examiner's information.
- \boxtimes In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent 3. application publications are not attached.
- \boxtimes An English language Abstract of the non-English language reference is attached hereto. See Reference No. 2.

5. U.S. Patent No. 6,541,278 (Reference No. 1) is the U.S. equivalent of CN 1264159 (Reference No. 2). Therefore, a copy of this reference is not submitted.

Respectfully submitted,

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Date: October 24, 2005

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Form PTO-1449 US Dept. of Commerce (REV. 8-83) PATENT & TRADEMARK OFFICE		e E	ATTY DOCKET NO. 117926			APPLICATION NO. 10/724,635			
INFORMATION DISCLOSURE STATEMENT									
(Use several sheets if necessary)			APPLICANT(S) Takeshi KIJIMA et al.						
			FILING I	DATE er 2, 2003	GROUP 1773				
	-	U.S.	PAT	ENT DOCU	JMENTS	L			
EXAMINER INITIAL	MINER		DATE		NAME			CLASS	SUB CLASS
	1)	6,541,278	12-	2003 MORITA et al.					
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	<u> </u>	FOREIC	IN P	ATENT DO	CUMENTS			1	_
		DOCUMENT NUMBER		DATE COUNTRY				CLASS	SUB CLASS
<u> </u>	2)	CN 1264159 (w/Abstract)		2000	CHINA			00/100	CLASS
-	<u> </u>	5) 61.120.125 (W.M.658.42C)				· · · · · · · · · · · · · · · · · · ·			
	 								
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		OTHER DOCUMENTS (Inc	ludir	ng Author,	<u> </u> Title, Date, Pertinent Pag	es, etc.)		I	
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EXAMINER					DATE CONSIDERED				
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in									

Date: October 24, 2005